



Attorney Docket No. 740756-2681

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:)	
Akiharu MIYANAGA et al.)	Group Art Unit: 1762
Application No. 10/728,987)	
Filed: December 8, 2003)	Examiner: W. Markham
For: PULSED PLASMA CVD METHOD)	Confirmation No.: 1100
FOR FORMING A FILM)	
(AS AMENDED))	April 11, 2005

AMENDMENT

Mail Stop **RCE**
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed December 9, 2004, and the Request for Continued Examination filed concurrently, please amend the above identified application as follows.

Amendments to the Specification begin on page 2 of this paper

Amendments to the Claims begin on page 5 of this paper.

Remarks begin on page 11 of this paper.